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2881
Docket No.: 0756-2409

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)

Koichiro TANAKA)

Serial No. 10/021,719)

Group Art Unit: 2881

Filed: December 19, 2001)

Examiner: Unassigned

For: LASER ANNEALING METHOD AND)

SEMICONDUCTOR DEVICE FABRICATION)

METHOD

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

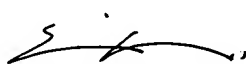
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Sir:

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To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


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